

Docket No.: M4065.0319/P319/A/A/

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Husam N. Al-Shareef, et al.

Application No.: 09/912,558

Filed: July 26, 2001

For: FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET

RAPID THERMAL OXIDATION PROCESS

Group Art Unit: 2813

Examiner: E. Kielin

APR 15.2002

AMENDMENT

Box Non-Fee Amendment

Commissioner for Patents Washington, DC 20231

Dear Sir:

In response to the Office Action dated February 15, 2002 (Paper No. 10), please amend the above-identified U.S. Patent application as follows:

In the Claims:

Please cancel claim 15.

Please rewrite claims 13, 14 and 41 as shown in the Replacement Claims:

1413842 v1; %@X#01!.DOC 1413842 v1; %@X#01!.DOC